

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination 10/565,430 OKAMOTO ET AL.	
		Examiner	Art Unit HUI CHIN	1796 Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	JP 2005008817 A	01-2005	Japan	OKAMOTO et al.	C08L 09/00
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#### NON-PATENT DOCUMENTS

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	U	Translation of JP2005008817, January 2005.
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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